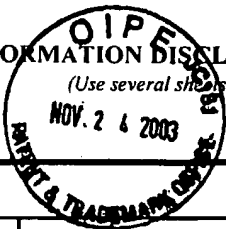


INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)
DC4960

Application Number
09/973,498

Applicant(s)
Chaudhury, et. al.

Filing Date
October 9, 2001

Group Art Unit
1713

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*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JTS		3,629,084	12/21/1971	Soldatos	204	168	
		5,497,033	3/5/1996	Fillion, et. al.	257	723	
		5,990,545	11/23/1999	Schueller, et. al.	257	697	
JTS		6,130,112	10/10/2000	Kitano, et. al.	438	108	

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
JTS		0 391 068	03/01/1990	Europe	—	—	✓	
JTS		0 430 476	11/09/1990	Europe	—	—	✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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2002 Electronic Components and Technology Conference, "Surface Activated Bonding for New Flip Chip and Bumpless Interconnect System", Tadatomo Suga, et. al., Institute for Advanced Micro-system Integration (IMSI), The University of Tokyo, RCAST, Toray Engineering Co. Ltd., 7 pages.

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JTK	4,639,285	1/27/87	Suzuki, et. al.	156	272.6	
	4,753,978	6/28/88	Jensen	524	862	
	4,766,176	8/23/88	Lee, et. al.	525	100	
	4,868,096	9/19/89	Nakayama, et. al.	430	329	
	4,897,153	1/30/90	Cole, et. al.	156	643	
	4,933,060	6/12/90	Prohaska, et. al.	204	192.36	
	5,017,654	5/21/91	Togashi, et. al.	525	100	
	5,110,845	5/5/92	Gray, et. al.	523	211	
	5,148,266	9/15/92	Khandros, et. al.	357	80	
	5,344,467	9/6/94	Huang, et. al.	44	358	
JTK	5,346,861	9/13/94	Khandros, et. al.	437	209	

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
JTK	JP 06-346034	12/20/94	Japan (abstract only)				
	JP 2000-73029	3/7/00	Japan (abstract only)				
	JP 11-277699	10/12/99	Japan (abstract only)				
	JP 09-214140	8/15/97	Japan (abstract only)				
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JTK	University of California, Los Angeles, Electronic Materials, Eli Yablonovitch, Vol. 9, pages 219-229.
JTK	Analytical Chemistry, David C. Duffy, et. al., "Rapid Prototyping of Microfluidic Systems in Poly(dimethylsiloxane)" Vol. 70, No. 23, December 1, 1998.

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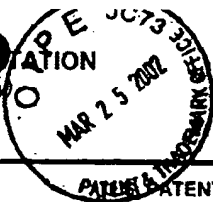
John T. Huran

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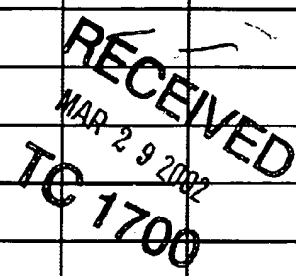
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FILING October 9, 2001	GROUP 1713

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JTA	5,347,159	9/13/94	Khandros, et. al.	257	692	
	5,357,005	10/18/94	Buchwalter, et. al.	525	436	
	5,477,611	12/26/95	Sweis, et. al.	29	840	
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	5,977,226	11/2/99	Dent, et. al.	524	267	
JTA	6,074,895	6/13/00	Dery, et. al.	438	108	

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
JTA	JP 08-153833	6/11/96	Japan (abstract only)				



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JTA	American Chemical Society, "Rate-Dependent Fracture at Adhesive Interface", Manoj K. Chaudhury, May 26, 1999, pages 6562-6566.
JTA	Adhesion '99, Seventh International Conference on Adhesion and Adhesives, Churchill College, Cambridge, UK, September 15 -17, 1999, "Adhesion Measurement of Silicone Thin Films," Bhukan Parbhoo and Manoj K. Chaudhury, pages 350 - 356.

EXAMINER <i>[Signature]</i>	DATE CONSIDERED 9/15/03
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